

PATENT APPLICATION

4319.70023

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant: Yuichiro Ohta

Serial No.: 10/796,344

Conf. No.: 1978

Filed: 3/9/2004

For: VACUUM PROCESSING  
APPARATUS

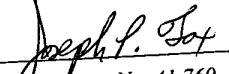
Art Unit: 1763

Examiner: Lund, Jeffrie Robert

) I hereby certify that this paper is being deposited with the  
United States Postal Service as FIRST-CLASS mail in an  
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this date.

) March 16, 2006

) Date  
F-CLASS WCM  
Appr. February 20, 1998

  
Registration No. 41,760

Attorney for Applicant(s)

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed December 16, 2005, please amend

the application as follows: